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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 9440**
Yuuko TOMEKAWA et al. : Attorney Docket No. 2006_0036A
Serial No. 10/567,017 : Group Art Unit 1709
Filed February 3, 2006 : Examiner Nathan H. Empie
METHOD FOR MANUFACTURING :
STAMPER FOR DIRECT MASTERING,
STAMPER MANUFACTURED BY THE :
METHOD, AND OPTICAL DISC

RESPONSE TO RESTRICTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975**

Sir:

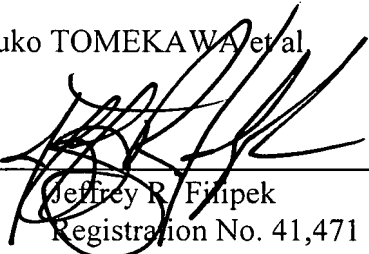
Pursuant to the requirement set forth in the Office Action mailed July 25, 2007, Applicants hereby elect invention I, claims 14-24, drawn to a method of manufacturing a stamper for direct mastering.

In view of this election, a full examination on the merits of the present application is respectfully requested.

Respectfully submitted,

Yuuko TOMEKAWA et al.

By:


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